



S/N 10/005667

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Qing Ma
Serial No.: 10/005667
Filed: November 2, 2001
Title: METHOD OF FABRICATING AN INTEGRATED CIRCUIT HAVING A MEMS DEVICE

Examiner: Jamie L. Brophy
Group Art Unit: 2822
Docket: 884.591US1

NOTIFICATION OF CORRESPONDENCE ADDRESS

Commissioner for Patents
Washington, D.C. 20231

Applicant recently received the Restriction Requirement mailed from the U.S. Patent Office on January 27, 2003 in connection with the above-identified application from the law firm of Williams, Morgan & Amerson, P.C.

The law firm of Williams, Morgan & Amerson, P.C. has never been associated with prosecution of the above-identified application. The address as listed on the Restriction Requirement is therefore completely erroneous and a request for correction the U.S. Patent Office records is hereby requested.

Applicant respectfully requests that all future correspondence in the above-identified patent application be addressed to:

Customer Number 21186, whose address is:

Schwegman, Lundberg, Woessner & Kluth, P.A.
P. O. Box 2938
Minneapolis, MN 55402

Respectfully submitted,
QING MA
By Applicant's Representatives,
SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
P.O. Box 2938
Minneapolis, MN 55402
612-349-9592

Date Feb. 26, 2003

By Ann M. McCrackin
Ann M. McCrackin
Reg. No. 42,858

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner of Patents, Washington, D.C. 20231, on this 26th day of February, 2003.

Anne M. Richards
Name

Anne M. Richards
Signature